

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Iwao Hatanaka

Art Unit: 2141

Serial Number: 09/781,616

Examiner: Luu

Filing Date: 02/12/2001

Confirmation No.: 9505

Title: METHOD AND SYSTEM FOR  
AUTOMATED SESSION RESOURCE  
CLEAN-UP IN A DISTRIBUTED  
CLIENT-SERVER ENVIRONMENT

Docket No.: CHA919990015US!  
(IBMC-0105)

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Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Dear Sir:

**I. Introductory Comments**

This paper is being filed in response to the Office Action dated May 27, 2008.

Reconsideration and allowance of the application are respectfully requested.